

Notice of References Cited	Application/Control No. 10/826,730	Applicant(s)/Patent Under Reexamination BEAUCHAINE ET AL.	
	Examiner Rakesh K. Dhingra	Art Unit 1763	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,277,194	08-2001	Thilderkvist et al.	117/94
*	B	US-6,450,346	09-2002	Boyle et al.	211/41.18
*	C	US-5,820,683	10-1998	Ishii et al.	118/728
*	D	US-2003/0170583	09-2003	Nakashima et al.	432/241
*	E	US-6,660,093	12-2003	Hamaguchi et al.	118/715
*	F	US-6,027,956	02-2000	Irissou, Pierre	438/68
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Google search - www.memsnets.org/material/polysilicon dated 02/20/06 (Pages 1-4).
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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